

Application/Control No.	Applicant(s)/Patent under Reexamination
09/760,646	WEI, LI
Examiner	Art Unit
Richard Chang	2663

	SEARCHED					
Class	Subclass	Date	Examiner			
370	412	4/27/2005	RIG			
370	468	4/27/2005	RIL			
370	516	4/27/2005	RIL KU			

INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		
370	412	4/27/2005	Ra		
370	468	4/27/2005	1211		
370	516	4/27/2005	kw		

SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
Chau Nguyen	4/7/2004	le(4		
Ricky Ngo	4/27/2005	RUC		